



AF/2815
IPW

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of: **Masatoshi FUKUDA et al.**

Group Art Unit: **2815**

Serial No.: **10/020,951**

Examiner: **Matthew C. Landau**

Filed: **December 19, 2001**

Confirmation No.: **8648**

For: **SEMICONDUCTOR DEVICE AND METHOD FOR FABRICATING
THE SAME**

Attorney Docket Number: **011724**

Customer Number: **38834**

AMENDMENT UNDER 37 CFR § 1.116

BOX: AF

Commissioner for Patents

P.O. Box 1450

Alexandria, Virginia 22313-1450

December 15, 2004

Sir:

In response to the Office Action dated September 16, 2004, Applicants amend the above-identified application as follows and submit the following remarks.

Amendments to the Claims are reflected in the listing of claims that begins on page 2 of this paper.

Remarks/Arguments begin on page 6 of this paper.